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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Grimbergen et al.	Group Art Unit: 1763
Application No: 09/667,362 Confirmation No: 9755	Examiner: Jeffrie Robert Lund
Filed: September 21, 2000	Attorney Docket No: 002813 USA P01/ETCH/SILICON/JB1
Title: REDUCING DEPOSITION OF PROCESS RESIDUES ON A SURFACE IN A CHAMBER	April 16, 2004 San Francisco, California

AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Via Facsimile Transmission
(703) 872-9306

Examiner Lund:

This communication is in response to the Office Action mailed on January 16, 2004 and is being timely filed within three months thereof.

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By:

Stephen Guzzi

Date: April 16, 2004

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GROUP ART UNIT: 1763
FIRM/CO. NAME: United States Patent and Trademark Office
APPLICATION NO: 09/667,362
FAX NO: (703) 872-9306
FROM: Ashok K. Janah
DATE: April 16, 2004
AMAT REFERENCE NO: 002813 USAP01/ETCH/SILICON/JB1

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MESSAGE:

Examiner,
Attached is a response to the Office Communication mailed on January 16,
2004.
Thanks,
Stephen Guzzi

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